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Plasma Science, 2000. ICOPS 2000. IEEE Conference Record - Abstracts. The 27th IEEE International Conference on , 4-7 June 2000

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L4 ANSWER 1 OF 2 COMPENDEX COPYRIGHT 2003 EEI on STN  
AN 2000(39):4318 COMPENDEX  
TI Investigation of magnetic guiding of laser plasmas for  
thin film deposition.  
AU Redman, D.G. (Univ of Alberta, Edmonton, Alberta, Can); Roupasov, S.;  
Tsui, Y.Y.; Rankin, R.; Capjack, C.E.; Fedosejevs, R.  
MT ICOPS 2000 - 27th IEEE International Conference on Plasma  
Science.  
MO IEEE Nuclear and Plasma Science Society  
ML New Orleans, LA, USA  
MD 04 Jun 1900-07 Jun 1900  
SO IEEE International Conference on Plasma Science 2000.p 142 2P17  
CODEN: 85PSAO ISSN: 0730-9244  
PY 2000  
MN 57169  
DT Journal  
TC Experimental  
LA English  
AB The application of a curved magnetic field to guide the laser produced  
plasma and direct it to the coating surface is proposed. It is directed to  
the coating surface while using a set of baffles to stop the particles  
which are not guided by the magnetic field from reaching the target. The  
ion flux at the exit of such a curved magnetic solenoid is characterized  
using a 20 ns duration 248 nm wavelength KrF laser pulse sources. 2 Refs.  
CC 744.9 Laser Applications; 932.3 Plasma Physics; 701.2 Magnetism: Basic  
Concepts and Phenomena; 714.2 Semiconductor Devices and Integrated  
Circuits; 802.3 Chemical Operations  
CT \*Laser produced plasmas; Deposition; Magnetic field effects; Thin films  
ST Magnetic guiding; Pulsed laser deposition  
ET F\*Kr; KrF; Kr cp; cp; F cp

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